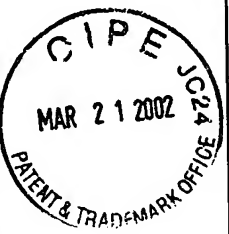


1765



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3
4-9-02

Applicant(s): Omstead, Thomas R.; Levy, Karl B.;
Title: ATOMIC LAYER DEPOSITION SYSTEMS AND METHODS
Serial No.: 10/028,610 Filed: December 19, 2001
Examiner: Unknown Group Art Unit: 1765
Docket No.: M-11953 US

San Jose, California
March 21, 2002

NOTICE OF CHANGE OF ADDRESS

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

Sir:

Please direct all correspondence in the above-identified application and with respect to
any patent that issues on this application to the undersigned at this address:

Greg J. Michelson
c/o SKJERVEN MORRILL MacPHERSON LLP
25 Metro Drive, Suite 700
San Jose, California 95110
Telephone: 949-718-5200

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Respectfully submitted,

Greg J. Michelson
Attorney for Applicant(s)
Reg. No. 44,940

TC 1700